

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the Application of: Fukashi HARADA et al.

Group Art Unit: 2811

Serial No.: 10/649,746 Examiner: Ori Nadav

Filed: August 28, 2003 Confirmation No.: 5719

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE INCLUDING AN ANISOTROPIC ETCHING STEP

Attorney Docket Number: 031071
Customer Number: 38834

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date: March 14, 2005

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated October 12, 2004 for two months from January 12, 2005 to March 12, 2005.

Attached please find a check in the amount of \$450.00 to cover the cost of the extension. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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